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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : SOPHIE et al.

Appl. No. : 09/975,466

Filed : October 9, 2001

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Examiner : Kielin, E.

) Group Art Unit 2813

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) *Adeel S. Akhtar*
) Adeel S. Akhtar, Reg. No. 41,394

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RESPONSE TO RESTRICTION REQUIREMENT

United States Patent and Trademark Office
P.O. Box 2327
Arlington, VA 22202

Dear Sir:

This paper is responsive to the Office Action mailed on July 23, 2002. Claims 1-32 are pending in the present application.

In the Office Action, the Examiner found that the claims were directed to two distinct inventions and required restriction to one. Applicants hereby elect Group I, claims 1-17 and 28-32, for the purposes of examination.

Applicant's submit that the present application is in condition for examination on the merits. If any issues remain, the Examiner is requested to telephone Applicants' counsel at the number provided below. Please charge any additional fees, including any fees for additional

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extension of time, or credit overpayment to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: August 20, 2002

By: Adeel S. Akhtar
Adeel S. Akhtar
Registration No. 41,394
Attorney of Record
2040 Main Street
14th Floor
Irvine, CA 92614
(415) 954-4114

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